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Patent
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Applicant(s): Hiroaki Saeki, et al.

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Examiner: To Be Assigned

For: TRANSFER SYSTEM FOR OBJECT TO BE PROCESSED, AND SEMICONDUCTOR/
FABRICATING SYSTEM WITH SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information

Disclosure Citation Form (PTO-1449) which lists the references cited in the International Search Report accompanying the national stage documents being filed on this same date. The relevance of JP 10-214875 and 9-23679 is described in the English language International Search Report.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

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